Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/662,382	KANAI ET AL.	
Examiner	Art Unit	
Chris C. Chu	2815	

SEARCHED				
Class	Subclass	Date	Examiner	
257	700 and 778 - 781	1/31/2006	C.C.	
	. —			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; and IBM_TDB;	1/31/2006	C.C.
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